

Patent

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Customer No.: 31561
Docket No.: 10573-US-PA
Application No.: 10/604,793

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Applicant : Rui-Hui Wen
Application No. : 10/604,793
Filed : 2003/8/18
For : ION SAMPLING SYSTEM FOR WAFER AND SAMPLING
METHOD THEREOF
Art Unit : 1746
Examiner : KORNAKOV, MICHAEL

TRANSMITTAL LETTER

002-1-571-273-8300

(Via fax : 1+7 pages)

Assistant Commissioner for Patents
Alexandria, VA 22314

Dear Sir,

In response to the Office Action dated May 18, 2006(Paper No.: 20060516), please find the Response to Office Action, in 7 pages.

I believe that no fee is incurred. However, the Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No. 50-2620 (Order No.: 10573-US-PA).

Thank you for your assistance in the subject matter. If you have any questions, please feel free to contact me.

Respectfully Submitted,
JIANQ CHYUN Intellectual Property OfficeDate : June 1, 2006By : Belinda Lee
Belinda Lee
Registration No.: 46,863

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Customer No.: 31561
Application No.: 10/604,793
Docket No.: 10573-US-PA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: KORNAKOV, MICHAEL

Group Art Unit: 1746

In re PATENT APPLICATION of

Applicant : Rui-Hui Wen

Serial No. : 10/604,793

Filed : August 18, 2003

For : ION SAMPLING SYSTEM FOR
WAFER AND SAMPLING
METHOD THEREOF

AMENDMENT

) Attorney Docket: 10573-US-PA
)
)

No fee is believed to be due. However, the Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No. 50-2620 (Order No.: 10573-US-PA)

RESPONSE TO RESTRICTION REQUIREMENT

United States Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Dear Sir:

The Office Action mailed on May 18, 2006 has been carefully considered.

In response thereto, please kindly consider the following amendments and remarks.

Customer No.: 31561
Application No.: 10/604,793
Docket No.: 10573-US-PA

AMENDMENTS

Please amend the application as indicated hereafter.

To the Title:

Please amend the title as follows,

~~"ION SAMPLING SYSTEM FOR WAFER AND SAMPLING METHOD THEREOF"~~